

Form 101-109		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1196		SERIAL NO. 09/388,063		
<div style="text-align: center;"> LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) </div>				APPLICANT Vishnu K. Agarwal		FILING DATE August 30, 1999		
				GROUP 2815				
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
[Signature]	AA	6,037,205	3/14/00	Huh et al				
	AB	5,470,398	11/28/95	Shibuya, et al.				
	AC	5,254,505	10/19/93	Kamiyama				
	AD	6,156,638	12/05/00	Agarwal et al.				
	AE	6,165,834	12/26/00	Agarwal et al.				
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
	AL							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
[Signature]	AM	WO 98/39497	09/11/98	Japan, Simpson, et al.				
	AN	0 474 140 A1	08/30/91	Europe, Kamiyama				
	AO	WO 99/64645	12/16/99	WIPO, Narwankar, et al.				
	AP							
	AQ							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
[Signature]	AR	JP	Kim, et al.: "Structural and Electrical Properties. . ." Applied Physics Letters, US, American Institute of Physics Vol. 65, No. 15, 10/10/94, Pgs. 1955 - 1957					
	AS	JP	Arai T., et al.: "Preparation of SrTiO ₃ Films on 8-Inch Wafers. . ." Jap. Journal of Applied Physics. Vol. 35, No. 9B, Part 01, 09/01/96, Pgs. 4875-4879.					
EXAMINER [Signature]				DATE CONSIDERED 11/14/01				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								